

00862.022199



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Keiji EMOTO) : Examiner: P. L. Rodriguez
Application No.: 09/833,766) : Group Art Unit: 2125
Filed: April 13, 2001) : Confirmation No.: 4154
For: PIPE STRUCTURE, ALIGNMENT APPARATUS,) : Allowed: November 10, 2004
ELECTRON BEAM LITHOGRAPHY) : January 27, 2005
APPARATUS, EXPOSURE APPARATUS,)
EXPOSURE APPARATUS MAINTENANCE)
METHOD, SEMICONDUCTOR DEVICE)
MANUFACTURING METHOD, AND SEMI-)
CONDUCTOR MANUFACTURING FACTORY)

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 CFR 1.312

Sir:

In response to the Notice of Allowance dated November 10, 2004, please amend the
above-identified application as follows: